



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ko et al.

Serial No.: 09/585,682

Filed: June 1, 2000

For: SEMICONDUCTOR DEVICE
HAVING A SUBSTRATE, AN UNDOPED
SILICON OXIDE STRUCTURE, AND AN
OVERLYING DOPED SILICON OXIDE
STRUCTURE WITH A SIDEWALL
TERMINATING AT THE UNDOPED
SILICON OXIDE STRUCTURE (Amended)

Confirmation No.: 7481

Examiner: C. Chu

Group Art Unit: 2815

Attorney Docket No.: 2269-3526.2US
(97-1136.02/US)

CERTIFICATE OF MAILING

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January 7, 2004
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Deirdra J. Pfeil
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C. L.

2/6/04

AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
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Sir:

This Amendment is being filed in response to the Final Office Action dated November 7, 2003, the three-month shortened statutory period for response to which expires on February 7, 2004. This response is being submitted within two months of the mailing date of the Final Office Action.

Amendments to the claims are set forth in the listing of the claims, which begins on page 2 of this paper; and

Remarks start at page 5 of this paper.

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